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PATENT
Attorney Docket No.: A8815/T54400

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

On March 7, 2005

TOWNSEND and TOWNSEND and CREW LLP

By: Kevin L. McNeill



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Laurent Vandroux et al.

Application No.: 10/808,160

Filed: March 23, 2004

For: IMPROVEMENT OF
GERMANIUM INTERFACE BY
REDUCTION OF NATIVE OXIDE
USING HYDROGEN-BASED PLASMA

Examiner: Lee, Calvin

Art Unit: 2825

REQUEST FOR CORRECTED FILING
RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a copy of the official Filing Receipt received from the Patent and Trademark Office in the above-noted application for which issuance of a corrected filing receipt is respectfully requested. The correction to the title is marked in red ink on the filing receipt, and should read as follows:

**REDUCTION OF NATIVE OXIDE AT GERMANIUM INTERFACE USING
HYDROGEN-BASED PLASMA**

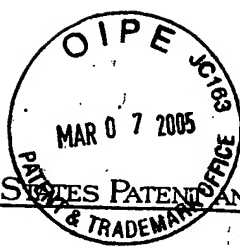
as evidenced by the Amendment to the Specification filed concurrently. A corrected filing receipt is respectfully requested. Applicant believes no fee is required for submission of this request. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



Patrick M. Boucher
Reg. No. 44,037

TOWNSEND and TOWNSEND and CREW LLP
Two Embarcadero Center, 8th Floor
San Francisco, California 94111-3834
Tel: (303) 571-4000
Fax: (303) 571-4321
PMB/nlm



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Page 1 of 2 B

UNITED STATES PATENT AND TRADEMARK OFFICE

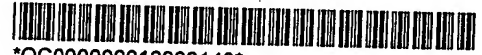
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/808,160	03/23/2004	2812	806	A8815/T54400	5	22	2

Patent Counsel, M/S 2061
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. Box 450A
Santa Clara, CA 95052

CONFIRMATION NO. 4812

FILING RECEIPT



OC000000012902140

Date Mailed: 06/08/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Laurent Vandroux, Saint Nazaire les Eymes, FRANCE;
Herve Monchoix, St. Imier, FRANCE;

Assignment For Published Patent Application

APPLIED MATERIALS, INC., Santa Clara, CA;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 06/08/2004

Projected Publication Date: 09/29/2005

Non-Publication Request: No

Early Publication Request: No

Title

~~Germanium interface by~~ reduction of native oxide using hydrogen-based plasma
AT GERMANIUM INTERFACE

Preliminary Class

438

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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Application Data Sheet

Application Information

Application number::	10/808,160
Filing Date::	03/23/04
Application Type::	Regular
Subject Matter::	Utility
Title::	IMPROVEMENT OF REDUCTION OF NATIVE OXIDE AT GERMANIUM INTERFACE USING HYDROGEN-BASED PLASMA
Attorney Docket Number::	A8815/T54400
Request for Early Publication::	No
Request for Non-Publication::	No
Total Drawing Sheets::	5
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	France
Status::	Full Capacity
Given Name::	Laurent
Family Name::	Vandroux
Country of Residence::	France
Street of Mailing Address::	2, chemin du moulin
Postal Address Line Two::	38339 Saint Nazaire les Eymes
Country of mailing address::	France

Applicant Authority Type::	Inventor
Primary Citizenship Country::	France
Status::	Full Capacity
Given Name::	Herve
Family Name::	Monchoix
City of Residence::	38330 St. Imier
Country of Residence::	France
Street of Mailing Address::	66, route de Biviers
City of Mailing Address::	38330 St. Imier
Country of mailing address::	France

Correspondence Information

Name Line One::	Patent Counsel, M/S 2061
Name Line Two::	APPLIED MATERIALS, INC.
Address Line One::	Legal Affairs Department
Address Line Two::	P.O. Box 450A
City::	Santa Clara
State or Province::	CA
Postal or Zip Code::	95052
Telephone::	303-571-4000
Fax::	415-576-0300

Representative Information

Representative Designation::	Representative Number::	Representative Name::
Primary	37,234	William L. Shaffer
Primary	25,610	Peter J. Sgarbossa
Primary	37,771	Joseph Bach
Primary	43,855	Loretta A. Peters
Primary	37,165	Raymond Kam-On Kwong

Primary	35,412	James C. Wilson
Primary	25,436	Robert W. Mulcahy
Primary	27,431	Robert C. Colwell
Primary	41,405	Chun-Pok Leung
Primary	40,456	Patrick R. Jewik
Primary	39,496	Kent J. Tobin
Primary	44,037	Patrick M. Boucher

Assignee Information

Assignee Name::	Applied Materials, Inc.
Street of mailing address::	3050 Bowers Avenue
City of mailing address::	Santa Clara
State or Province of mailing address::	CA
Country of mailing address::	US
Postal or Zip Code of mailing address::	95054